

## PATENT ASSIGNMENT COVER SHEET

Electronic Version v1.1  
 Stylesheet Version v1.2

EPAS ID: PAT3395536

<b>SUBMISSION TYPE:</b>	NEW ASSIGNMENT
<b>NATURE OF CONVEYANCE:</b>	ASSIGNMENT
<b>CONVEYING PARTY DATA</b>	
<b>Name</b>	<b>Execution Date</b>
ADVANCED ION BEAM TECHNOLOGY, INC.	05/29/2015
<b>RECEIVING PARTY DATA</b>	
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<b>State/Country:</b>	TAIWAN
<b>Postal Code:</b>	300
<b>PROPERTY NUMBERS Total: 1</b>	
<b>Property Type</b>	<b>Number</b>
Patent Number:	8653807
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<b>DATE SIGNED:</b>	06/12/2015
<b>Total Attachments: 1</b>	
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## ASSIGNMENT

WHEREAS, **ADVANCED ION BEAM TECHNOLOGY, INC.**, (hereinafter referred to as ASSIGNOR), a corporation legally organized under the laws of U.S.A., having its principal place of business at **81 DAGGETT DRIVE, SAN JOSE, CALIFORNIA 95134**, is the owner of the Patent listed below, and;


WHEREAS, **ADVANCED ION BEAM TECHNOLOGY, INC.**, (hereinafter referred to as ASSIGNEE), a corporation legally organized under the laws of Taiwan, R.O.C, having its principal place of business at **5F, NO. 18, CREATION ROAD 1, SCIENCE PARK HSIN-CHU 300, TAIWAN**, is desirous of acquiring the exclusive right, title and interest in and to the said Patent listed below.

NOW THEREFORE, for good and valuable consideration, the receipt and sufficiency of which is hereby acknowledged, **ADVANCED ION BEAM TECHNOLOGY, INC.**, does hereby sell, assign, and transfer to, **ADVANCED ION BEAM TECHNOLOGY, INC.**, its successors and assigns, its entire right, title and interest in and to the said Patent listed below, together with the goodwill associated therewith.

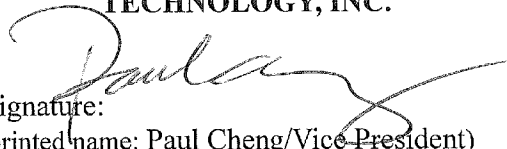
**ADVANCED ION BEAM TECHNOLOGY, INC.**, agrees to execute and deliver to, **ADVANCED ION BEAM TECHNOLOGY, INC.**, all further documents as may be reasonably necessary to give effect to the assignment of rights reflected herein.

US filing No.	US Patent No.	Title
12/841,833	8,653,807	APPARATUS AND METHOD FOR MEASURING ION BEAM CURRENT

Assignor: **ADVANCED ION BEAM TECHNOLOGY, INC.**

Signature:   
(printed name: Daniel Tang/President)  
Date: May 29, 2015

Assignee: **ADVANCED ION BEAM TECHNOLOGY, INC.**

Signature:   
(printed name: Paul Cheng/Vice-President)  
Date: May 29, 2015